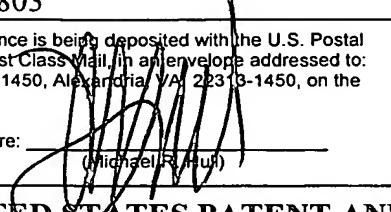


Application No.: 10/628,803

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below:

Dated: August 3, 2005

Signature: 

(Michael R. Hull)

Docket No.: 29936/39432

Docket No.: 29936/39432
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Sung Hoon Lee

Application No.: 10/628,803

Confirmation No.: 4537

Filed: July 28, 2003

Art Unit: 1765

For: METHOD OF FORMING ISOLATION FILM
OF SEMICONDUCTOR DEVICE

Examiner: Lan Vinh

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendmetn
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

Amendments to the specification appear on page 2 of this paper.

Amendments to the claims and a complete listing of the claims begin on page 4 of this paper.

Remarks in support of the allowability of this application begin on page 6 of this paper.